
**Implants for surgery —
Hydroxyapatite —**

**Part 3:
Chemical analysis and
characterization of crystallinity ratio
and phase purity**

AMENDMENT 1

Implants chirurgicaux — Hydroxyapatite —

*Partie 3: Analyse chimique et caractérisation du rapport de
cristallinité et de la pureté de phase*

AMENDEMENT 1

ISO 13779-3:2018/Amd 1:2021

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